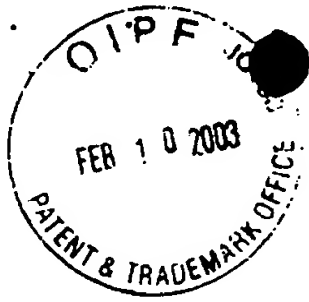


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PATENT

1765  
#210  
- 1/103  
(1765)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: Kozo Nakamura, et al.

Serial No.: 09/856,212

Filed: May 18, 2001

For: Production Method For Silicon Single Crystal  
And Production Device For Single Crystal  
Ingot, And Heat Treating Method For Silicon  
Single Crystal Water

) Group Art Unit: 1765

)

) I hereby certify that this correspondence

) is being deposited with the United States

) Postal Service as first class mail in an

) envelope address to: Assistant

) Commissioner of Patents, Washington, DC

) 20231, on February 4, 2003.

)

)

)

) Gerald T. Shekleton Reg. No. 27,466 Date

)

Examiner: Matthew J. Song

AMENDMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

The Office Action of November 5, 2002 has been carefully reviewed and the following  
amendments/remarks are made in response thereto.

IN THE CLAIMS

Please amend Claims 1-5, 7 and 9-11 as follows:

1. (Amended) A method for producing a relatively defect free silicon single crystal  
ingot under the following conditions:



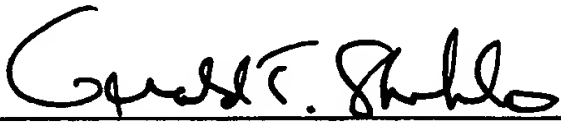
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IFW 1722 ✓

PATENT  
Attorney Docket No. 1110/82821

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application	)	Confirmation No.: 6761
Applicant: Kozo Nakamura, et al.	)	
Serial No.: 09/856,212	)	<i>I hereby certify that this correspondence is</i>
Filed: May 18, 2001	)	<i>being deposited with the United Postal</i>
For: <b>PRODUCTION METHOD</b>	)	<i>Service as first class mail in an envelope</i>
<b>FOR SILICON SINGLE</b>	)	<i>addressed to: Mail Stop AMENDMENT,</i>
<b>CRYSTAL AND</b>	)	<i>Commissioner of Patents, P.O. Box 1450,</i>
<b>PRODUCTION DEVICE FOR</b>	)	<i>Alexandria, VA, 22313-1450.</i>
<b>SINGLE CRYSTAL INGOT,</b>	)	
<b>AND HEAT TREATING</b>	)	<b><u>June 28, 2006</u></b>
<b>METHOD FOR SILICON</b>	)	
<b>SINGLE CRYSTAL WAFER</b>	)	
Examiner: Matthew J. Song	)	Gerald T. Shekleton Reg. No. 27,466
Art Unit: 1722	)	

AMENDMENT

Mail Stop AMENDMENT  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The Office Action of March 3, 2006 has been carefully reviewed and the following amendments and remarks are made in response thereto.